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MAR 10 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Case No. 207.009-US)

In the Application of: Lutz et al.)	Group Art Unit: 2813
)	
Serial No: 10/777,326)	Examiner: David S. Blum
)	
Filed: February 12, 2004)	
)	
Title: Integrated Getter Area for Wafer Level Encapsulated Microelectromechanical Systems)	
)	

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136(a)

Applicants hereby petition for a **two (2) month** extension of time to extend the period for filing a reply in the above-identified application.

The Commissioner is hereby authorized to charge any fees which may be required to Deposit Account No. 50-0763. A duplicate copy of this sheet is attached.

Respectfully submitted,



Neil A. Steinberg, Reg. No. 34,735
Telephone No. 650-968-8079

Date: March 10, 2006

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